

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Group Art Unit: ~~Not yet assigned~~ 3652
Raymon F. Thompson et al)
Serial No.: ~~Not yet assigned~~ 09/575551)
Filed: Herewith 5/22/00)
For: SEMICONDUCTOR PROCESSING)
SYSTEM WITH WAFER)
CONTAINER DOCKING AND)
LOADING STATIONS)

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Prior to examination on the merits, please amend the above-identified application as follows

(with reference to the line numbers at the left margin):

IN THE SPECIFICATION

At page 1, delete lines 1-3, and add -- This application is a continuation of U.S. Patent

Application Serial No. 09/193,746, filed November 17, 1998 and now abandoned, which is a

FROM 6/99


CERTIFICATE OF MAILING
(37 C.F.R. §1.10)

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as 'Express Mail Post Office To Addressee' in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

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